

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/757,252  
Filing Date .... January 13, 2004  
Inventor ..... Denise M. Eppich et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 1811  
Examiner ..... Unknown  
Attorney's Docket No. .... MI22-2468  
Title: CMOS Constructions and Capacitor Constructions

COPY

INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

The citations listed may be material to the examination of the subject application and are therefore submitted in compliance with the duty of disclosure defined in 37 CFR §1.56. Copies of the cited art are included with the exception of U. S. patents and published U. S. applications (1276 Off. Gaz. Pat. Off., 05 August 2003). No admission is made regarding whether all the submitted references are prior art. The Examiner is requested to make these citations of official record in this application. No admission is made regarding whether all the submitted references are prior art.


The materials cited are presented to assist in and expedite examination of this application. The present invention is considered to be patentable over the cited materials. Expeditious examination and allowance of this application as a patent are therefore urged in order that the public may benefit from the disclosure and commercialization of the invention.

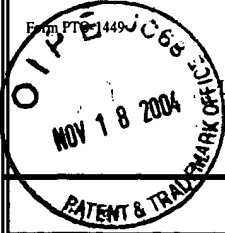
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Citation of these references is respectfully requested.

Respectfully submitted,

Date: 10/4/04

By:   
David G. Latwesen, Ph.D.  
Reg. No.: 38,533

		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2468		SERIAL NO. 10/757,252		
		LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)						
		APPLICANT Denise M. Eppich et al.				FILING DATE January 13, 2004		GROUP 2811
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,228,702	05/01	Hirota				
	AB	6,277,702	08/01	Chun et al.				
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		Document Number	Date	Country	Class	Subclass	Translation	
							Yes No	
	AL	2004/006584	03/04	PCT Search Report				
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	AN	10 303412	11/98	JP - Abstract only				
	AO	2001 339061	12/01	JP - Abstract only				
	AP							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AR							
	AS							
	AT							
EXAMINER				DATE CONSIDERED				
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>								

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